

## Detailed Analysis of Temperature and Pressure Behaviour During Reaction Runaway for Vent Sizing

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Yuichiro Izato<sup>2)</sup>, Atsumi Miyake<sup>2)</sup>

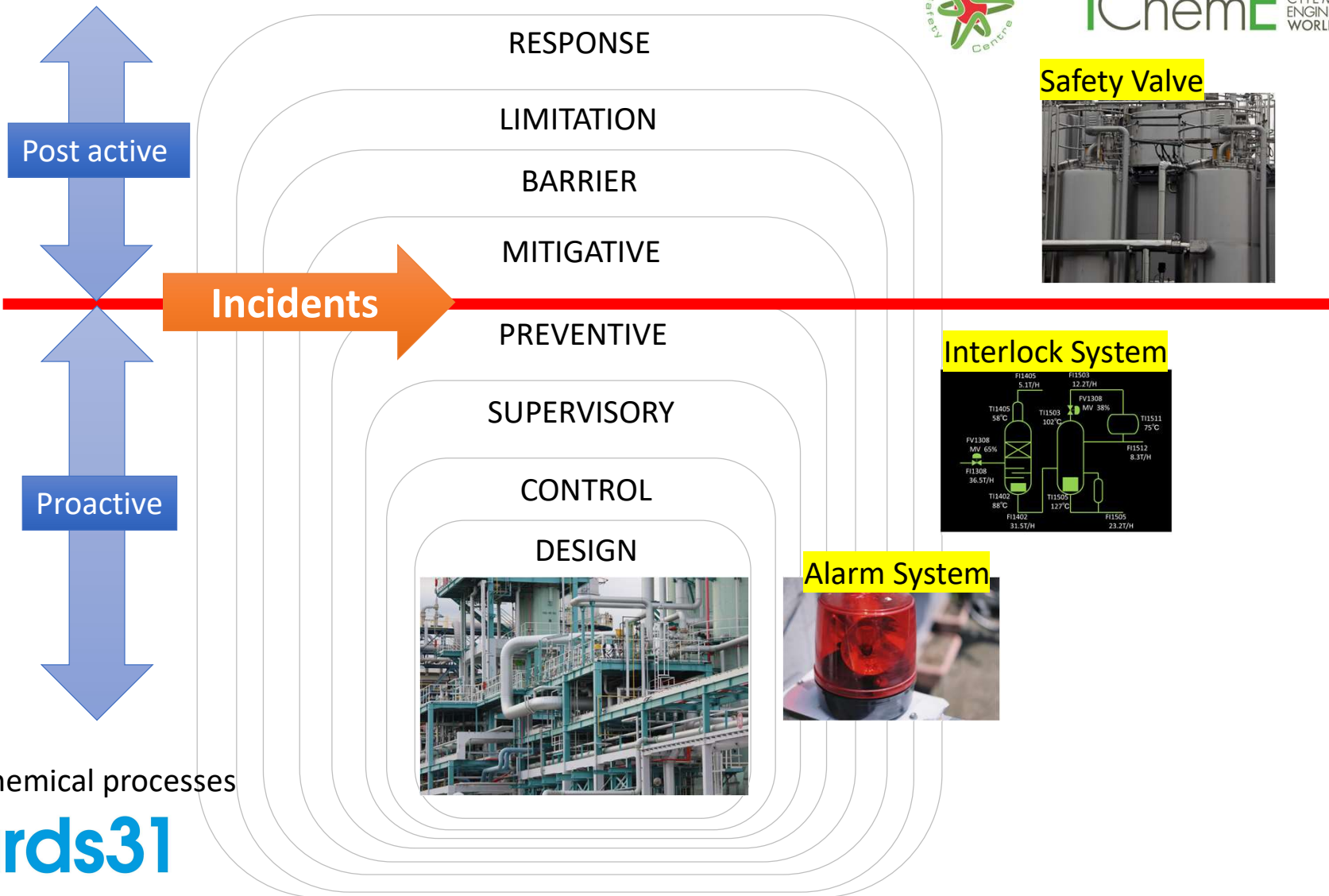
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<sup>2)</sup> Yokohama National University, Japan

# Safety measures in the Chemical Plants



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CCPS Guidelines for safe automation of chemical processes

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# The regulations for vent sizing



## Regulation of vent sizing for two-phase flow

- US: API STD 520 (2008)
- EU: ISO 4126-10 (2010)
- Japan: JIS B 8227 (2013)

Translated guideline of ISO

### ISO - Procedures

Determination of reaction system

- Tempered System
- Gassy System
- Hybrid System

Determination of release phase

- Gas Phase Flow
- Two Phase Flow

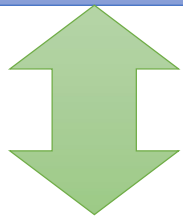
Calculation of vent size

# The features of ISO and actual process



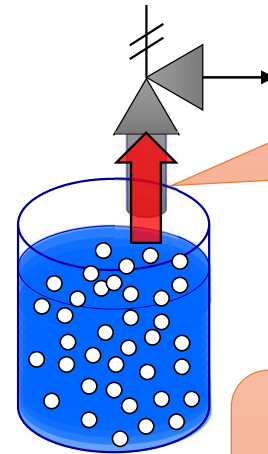
## ISO method

- (a) The most violent runaway reaction starts at initial liquid level
- (b) Assumed confined equipment



## Actual processes

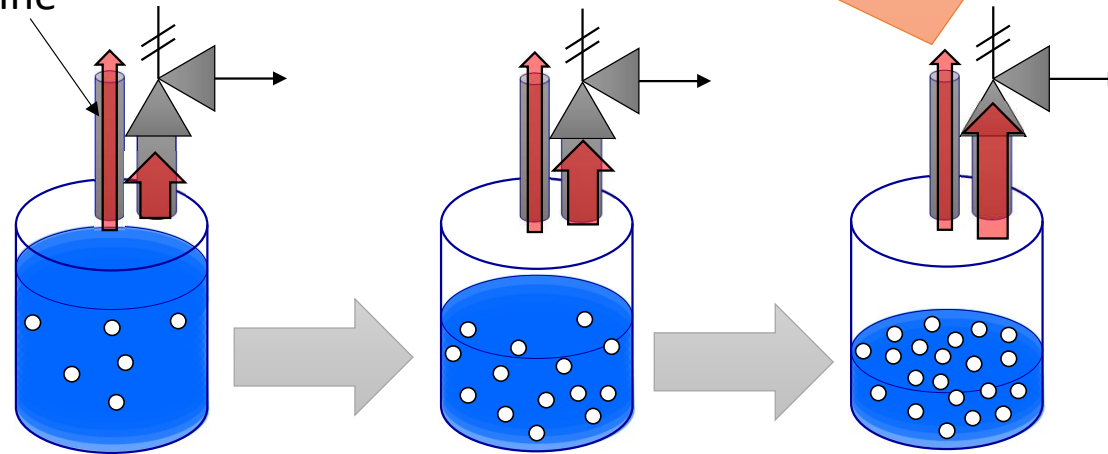
- (a) Liquid decrease during runaway reaction
- (b) Many equipment are unconfined



(a) Max. generation rate from Max. Liquid level

(b) The influence of release from exhaust line?

Exhaust line



# Model Process for dynamic simulation

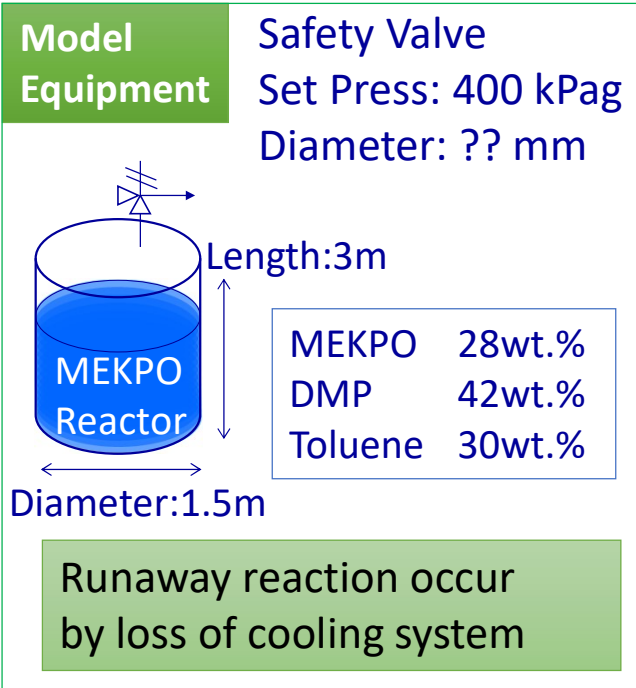
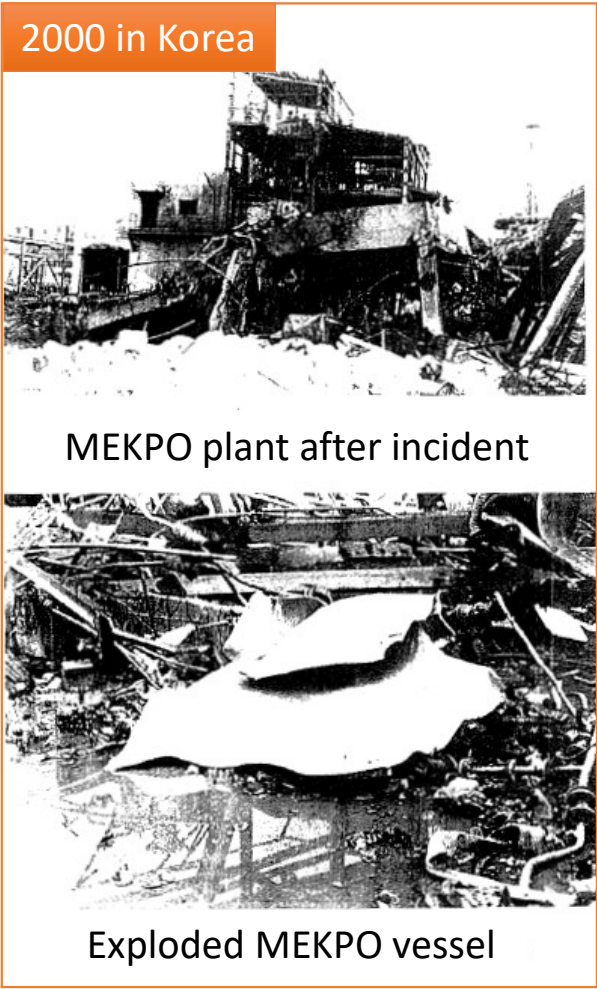


## MEKPO thermal explosion incidents in Japan, Taiwan, Korea and China

Date	Country	City	Injuries	Fatalities
1964	Japan	Tokyo	114	19
1978	Japan	Kanagawa	0	0
1979	Taiwan	Taipei	49	33
1996	Taiwan	Taoyuan	47	10
2000	Korea	Yosu	11	3
2001	China	Jiangsu	2	4
2003	China	Zhejiang	3	5

Thermal Hazard Simulations for Methyl Ethyl Ketone Peroxide Induced by Contaminants Jo-Ming Tseng, Korean J. Chem. Eng., 22(6), 797-802 (2005)

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# Procedures of dynamic simulation



Aspen Dynamics

Aspen Custom Modeler

Runaway reaction test

### Define reaction model

- Reaction formula
- Mass balance
- Heat of formation

### Validation of runaway test

- Temperature and pressure rise behavior
- Maximum temperature

### Safety valve model

- ISO Omega-method
- Create algorithm of SV open/close
- Create algorithm of single/two phase flow
- Incorporation to Aspen Dynamics

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Vent sizing

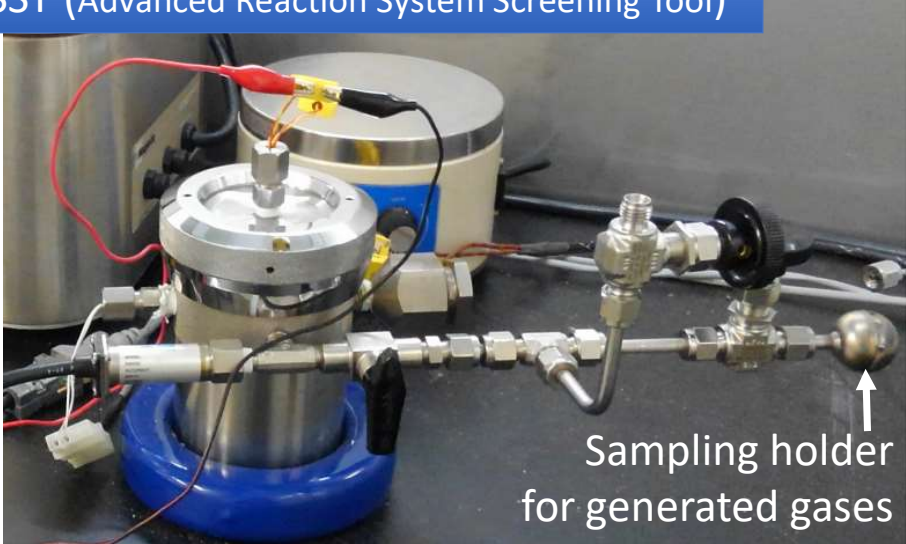
- Considering
- Liquid decrease
  - Exhaust gas line



# Definition of products and mass balance



ARSST (Advanced Reaction System Screening Tool)



Sampling holder for generated gases



## Gas chromatography

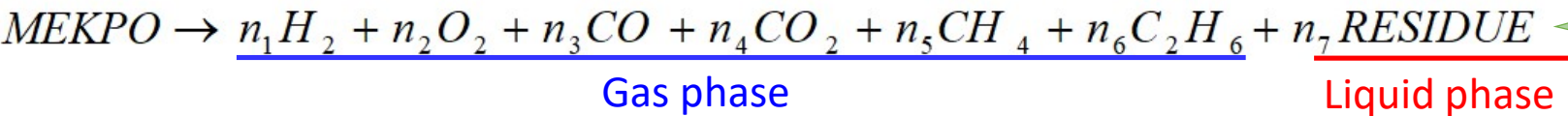
CHROMATOGRAM 1 MEMORIZ

C-R5A CHROMATOPAC  
CHANNEL NO 1  
SAMPLE NO 8  
REPORT NO 6

PKNO	TIME	AREA
1	1.222	241
2	1.603	59793
3	1.946	5168201
4	3.648	20873
5	4.709	53883
6	7.919	187896
7	9.843	10798
8	11.44	61596
9	17.169	2336
10	18	585
11	19.763	23833
TOTAL		5590034

## Composition(%)

H2	3
O2	18
CO	15
CO2	44
C1	7
C2	11



$C_x H_y O_z$   
x, y, z: decimal number

- Reaction Formula
- Mass Balance
- Heat of Formation of MEKPO and RESIDUE

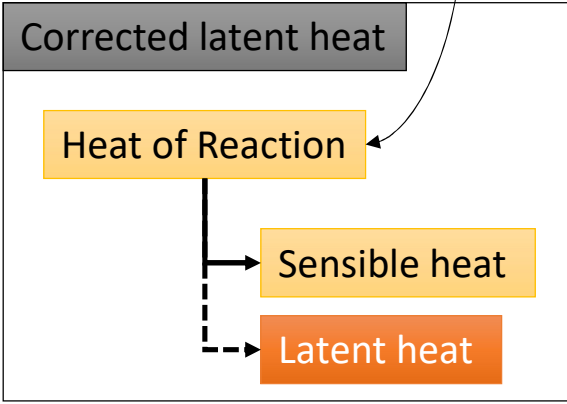
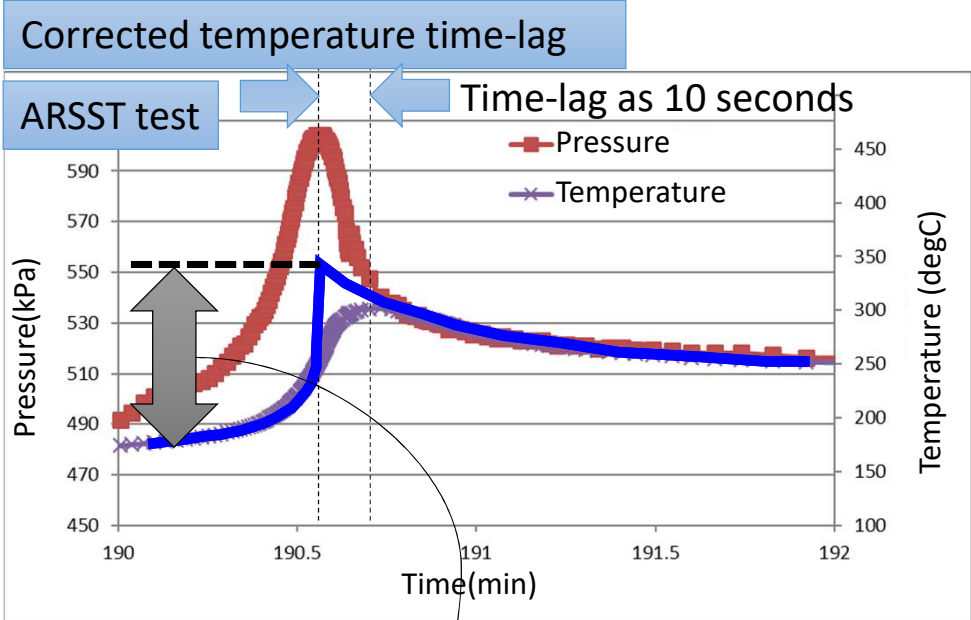
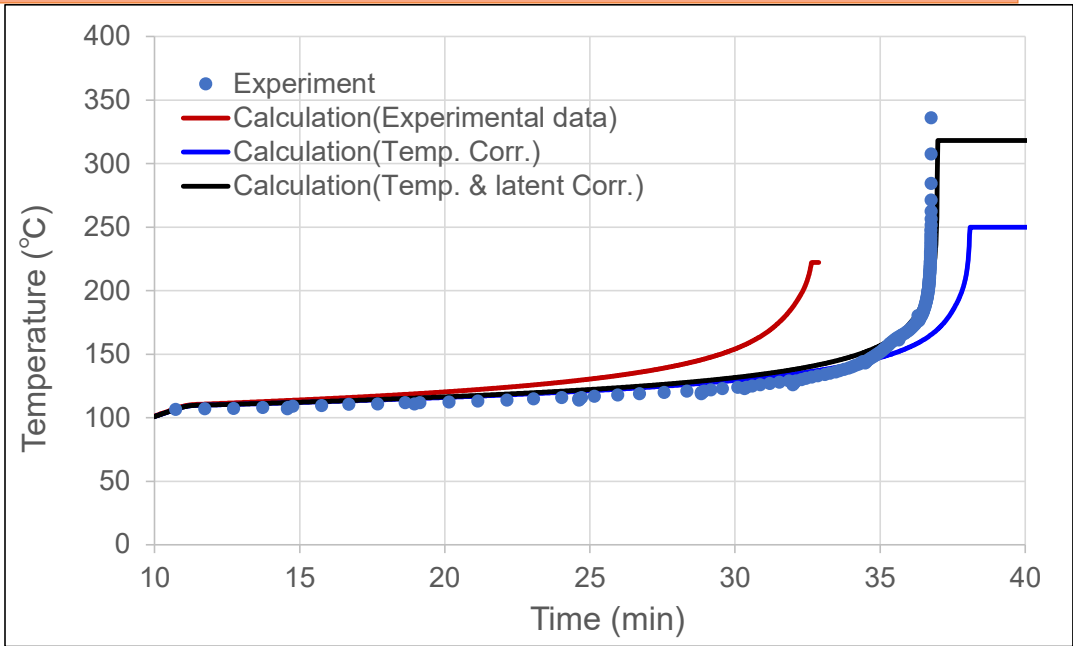
# Definition of reaction rate



Arrhenius type equation with thermal conversion by ARSST test

$$\frac{dr}{dt} = \frac{d}{dt} \left\{ n_0 \Big|_{MEKPO} \left( 1 - \frac{T - T_0}{\Delta T_{max}} \right) \right\} = A_{pre} \exp \left( \frac{-Ea}{RT} \right)$$

Comparison among experimental data and calculations





# Procedures of dynamic simulation



Aspen Dynamics

Aspen Custom Modeler

Define reaction model

- Reaction formula
- Mass balance
- Heat of formation

Validation of runaway test

- Temperature and pressure rise behavior
- Maximum temperature

Programing subroutine

Safety valve model

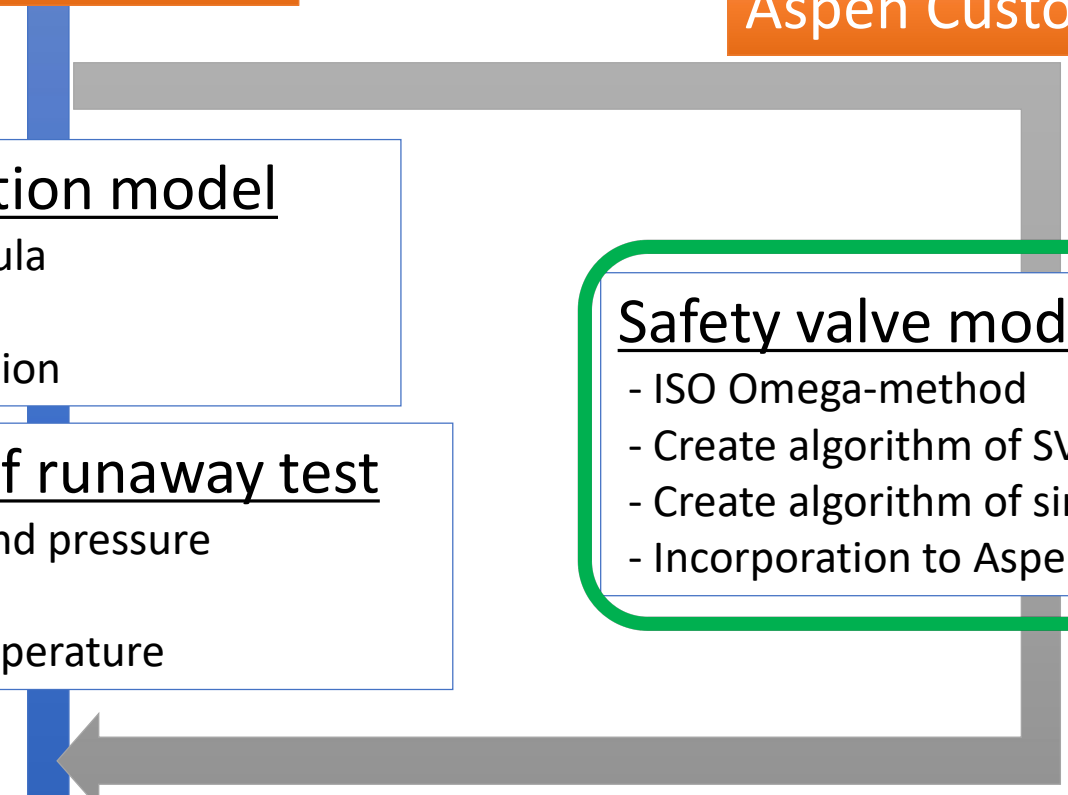
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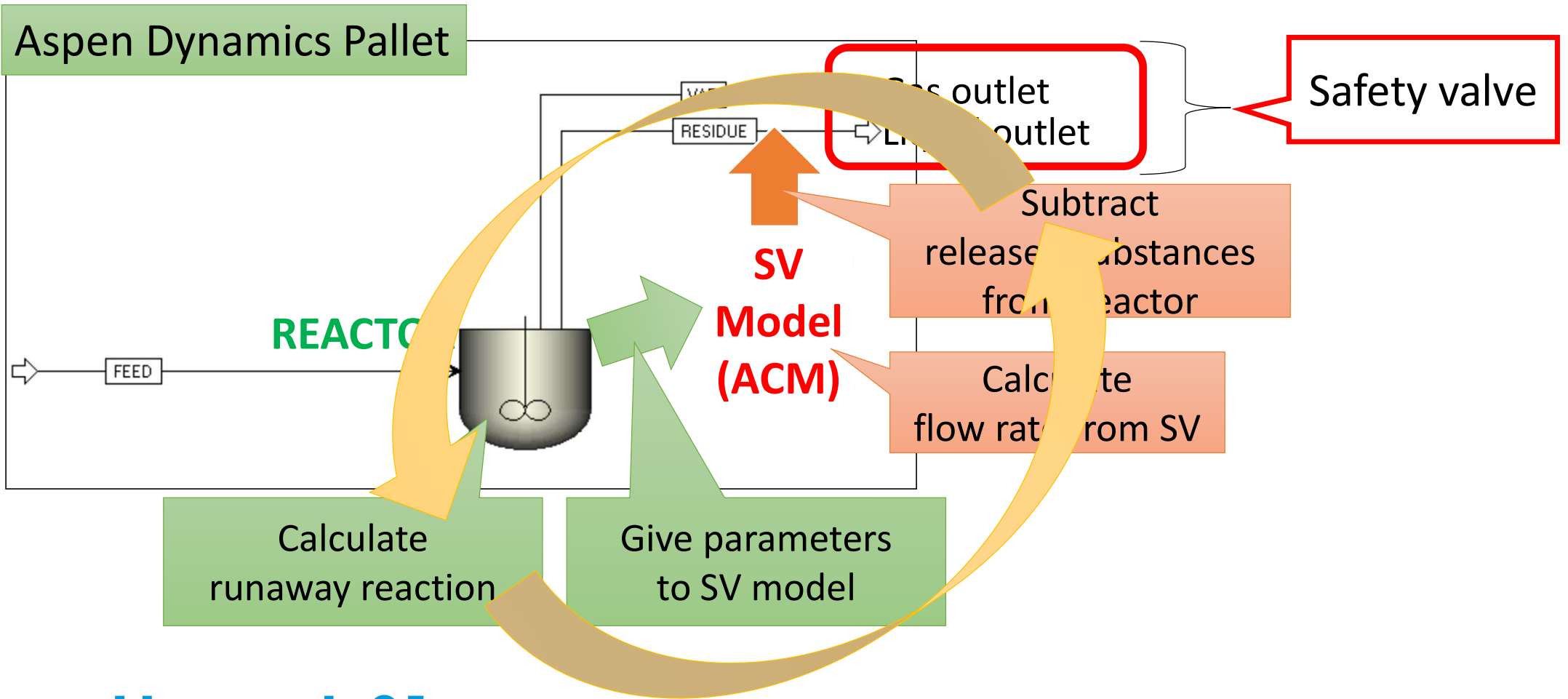
Vent sizing

Considering

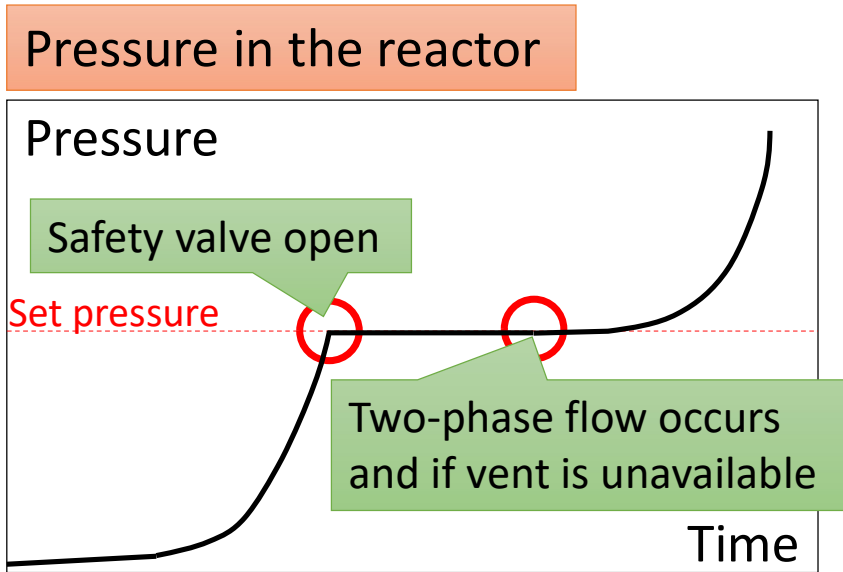
- Liquid decrease
- Exhaust gas line



# Interaction of Aspen Dynamics and ACM



# Runaway reaction in the reactor



## Runaway reaction occur in the reactor

Temperature rise

- Pressure rise by
- 1. Gas generation ← Reaction formula
  - 2. Vapor pressure ← Equilibrium
  - 3. Volume expansion ← Equation of state

Pressure rise

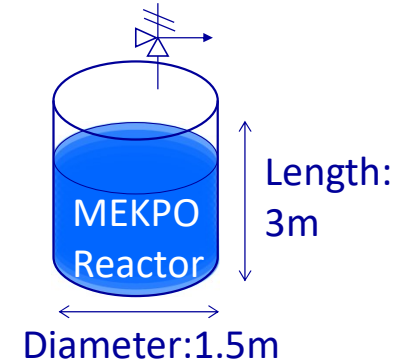
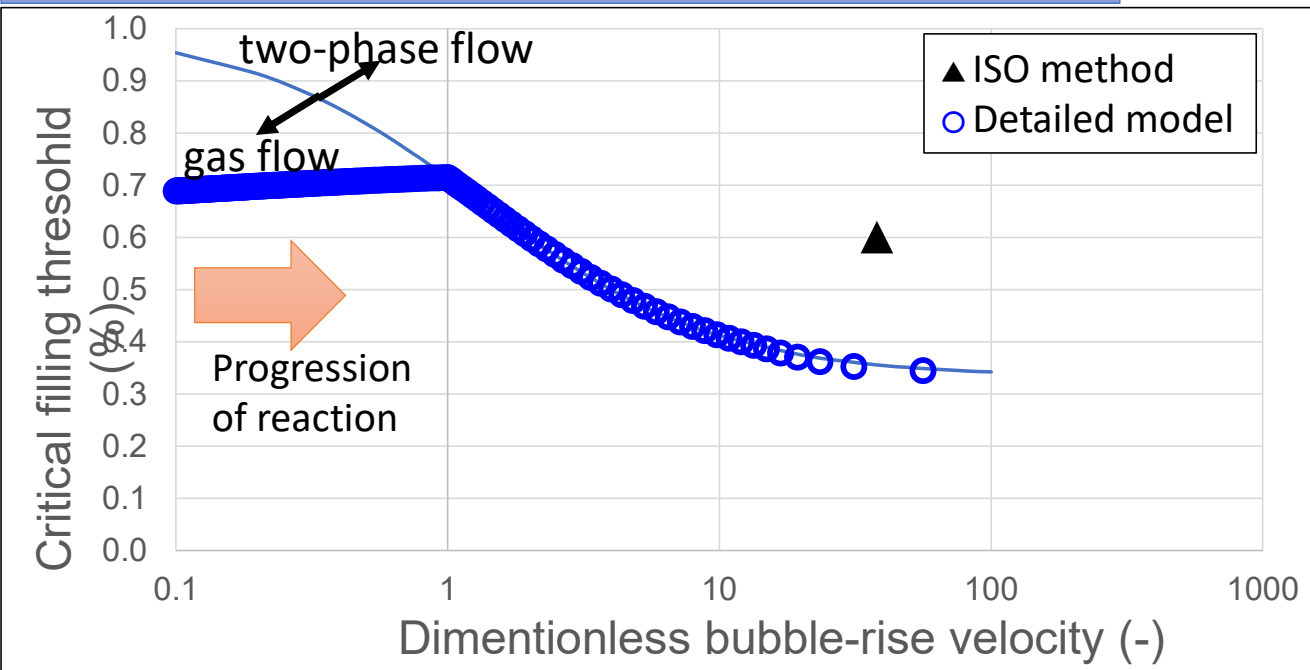
Two-phase flow occur if reaction speed go through boundary line of **flow regime**

Depressurization from safety valve

# Runaway behavior on flow regime and estimated vent size



## Flow regime for occurrence of two-phase flow



Analysis method	Vent size [m]
ISO method	1.9
Detailed model	0.5

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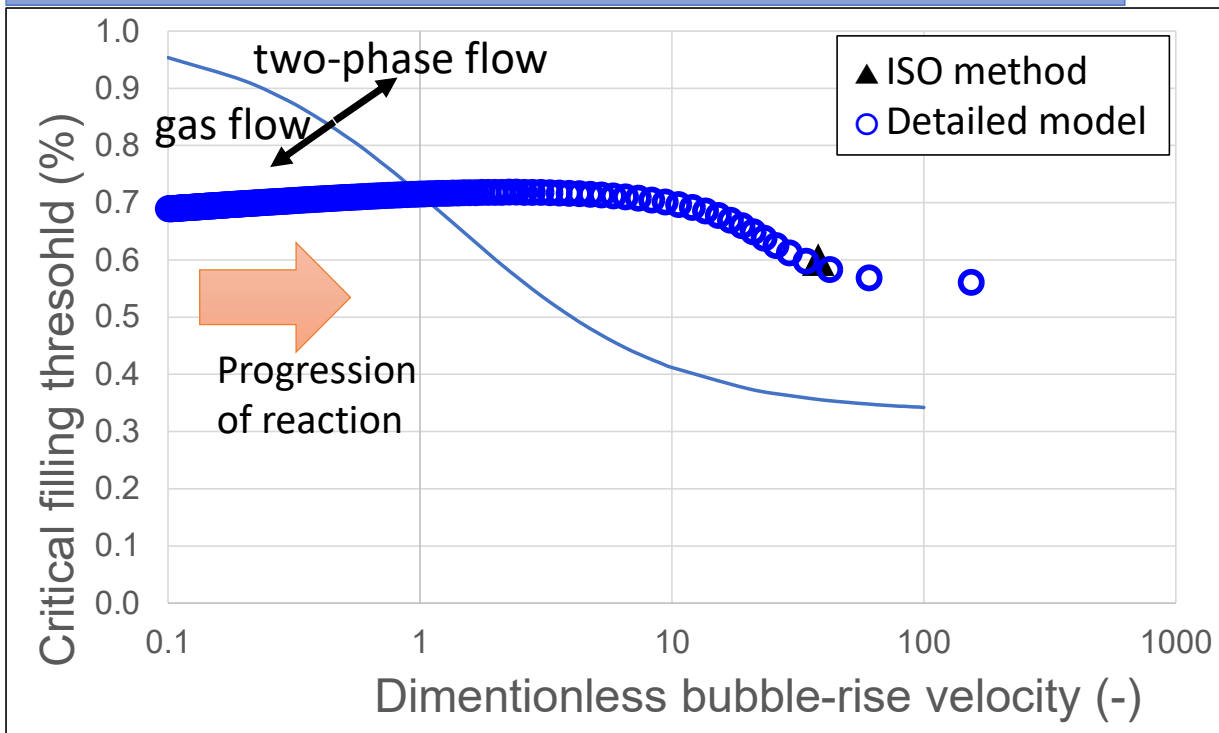
Considering liquid decrease gives reasonable vent size

# Comparison of gas and vapor generation rate



In detailed model, liquid did not release for comparison to ISO

## Flow regime for occurrence of two-phase flow



No liquid release

	ISO method	Detailed model
Gas generation rate [kg/sec]	79	64
Vaporization rate [kg/sec]	-	320
Vent size [m]	1.9	3.1

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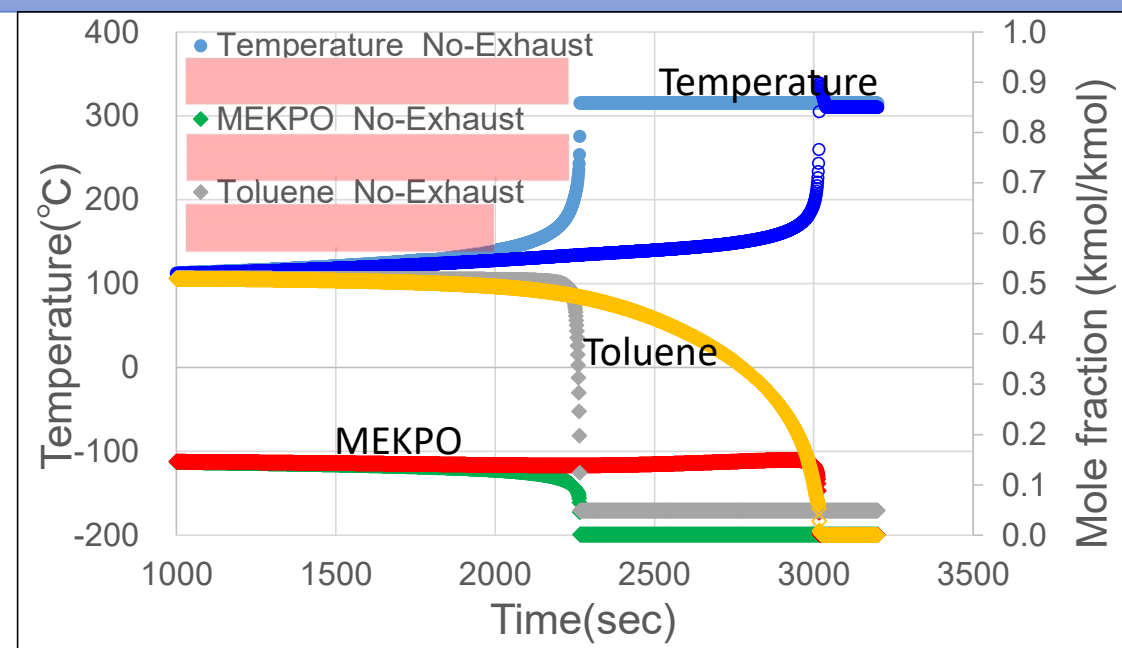
ISO-ARSST not considering vaporization rate could underestimate vent size

# Vent sizing considering exhaust gas line



	Confined reactor	with exhaust gas line
Max. temperature [°C]	315	339
Gas generation rate [kg/sec]	19	56
Vaporization rate [kg/sec]	129	238
Vent size [m]	0.5	0.7

## Temperature and concentration in runaway reaction



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All vaporization of solvents leads to concentrate reactive chemicals and required vent size was larger



# Summary and future work



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## Summary

- Detailed model considering liquid decrease and exhaust gas line is developed
- Considering liquid decrease gives reasonable vent size
- ISO-ARSST not considering vaporization rate could underestimate vent size
- All vaporization of solvents leads to concentrate reactive chemicals and required vent size was larger

## Future work

- Small-scale runaway reaction experiment
- Enhance for monomer and foamy substances

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# Thank you for your attention!

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